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SEP 22 2006

Atty. Docket No. PLA31071

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Ki-Min LEE

: GROUP ART UNIT: 2818

APPLICATION NO: 10/750,489

:

FILED: December 31 , 2003

: EXAMINER: Calvin LEE

FOR: METHODS OF MANUFACTURING
METAL-INSULATOR-METAL
CAPACITORS OF HIGH
CAPACITANCE IN
SEMICONDUCTOR DEVICES

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2006.

By: 

Jennie Heaton

REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132 AND 37 C.F.R. 1.116

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SIR:

Responsive to the Office Action dated May 22, 2006, Applicant respectfully requests reconsideration of the above-identified application in view of the following remarks.